Attorney's Docket No.: 14219-097US1 Applicants: Ruile, et al. Client's Ref. No.: P2003,0034 US N

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AMENDMENTS TO THE CLAIMS (THIS LISTING REPLACES ALL PRIOR LISTINGS):

Claims 1-24. (Canceled).

25. (New) An apparatus comprising:

a piezoelectric substrate comprising at least one transducer electrode structure comprising:

a metallization formed by one or more metals, the one or more metals having a mean specific density that is at least 50% higher than that of aluminum; and

a compensation layer applied fully or partially over the metallization, the compensation layer being of a material having a temperature dependence of elastic constants that substantially counteracts a temperature coefficient of frequency of the substrate, the compensation layer having a thickness that is less than 15% of an acoustic wavelength of a wave capable of propagation in the structure.

- 26. (New) The apparatus of claim 25, wherein the elastic constants of the metallization have less temperature dependency than elastic constants of aluminum.
- 27. (New) The apparatus of claim 25, wherein the metallization comprises one or more of the following: copper, molybdenum, tungsten, gold, silver and platinum.
- 28. (New) The apparatus of claim 25, wherein the compensation layer comprises SiO₂.
- 29. (New) The apparatus of claim 25, wherein the metallization comprises copper or a copper alloy and has a thickness of 6 to 14% h/λ .

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30. (New) The apparatus of claim 25, wherein the compensation layer has a thickness of 4 to 10% h/λ .

- 31. (New) The apparatus of claim 25, wherein the substrate comprises lithium tantalate with a rotated cut.
- 32. (New) The apparatus of claim 25, wherein the substrate comprises lithium tantalate with a rotated cut and an angle of intersection of between 30 and 48°.
- 33. (New) The apparatus of claim 25, wherein the substrate comprises lithium niobate.
- 34. (New) The apparatus of claim 25, wherein the substrate comprises quartz.
- 35. (New) The apparatus of claim 25, further comprising an adhesive layer beneath the metallization.
- 36. (New) The apparatus of claim 35, wherein the adhesive layer comprises one or more of the following: aluminum, molybdenum, titanium, tungsten, chromium, and nickel.
- 37. (New) The apparatus of claim 35, wherein the adhesive layer has a thickness of 1 to 7 nm.
- 38. (New) The apparatus of claim 25, wherein the compensation layer comprises SiO₂ with a refractive index of between 1.43 and 1.49.
- 39. (New) The apparatus of claim 25, wherein the temperature coefficient of frequency is less than 20 ppm/K.

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40. (New) The apparatus of claim 25, further comprising a passivation layer that is thinner than the compensation layer, the passivation layer being beneath the compensation layer.

- 41. (New) The apparatus of claim 25, wherein the apparatus comprises a multiport filter.
- 42. (New) The apparatus of claim 25, wherein the apparatus comprises a reactance filter.
- 43. (New) The apparatus of claim 25, wherein the apparatus comprises a dual mode surface acoustic wave filter.
- 44. (New) The apparatus of claim 25, wherein the apparatus comprises a single phase uni-directional transducer filter.
- 45. (New) The apparatus of claim 25, wherein the apparatus comprises a duplexer.
- 46. (New) The apparatus of claim 25, wherein the apparatus comprises a diplexer.
- 47. (New) The apparatus of claim 25, wherein the apparatus comprises a 2-in-1 filter.